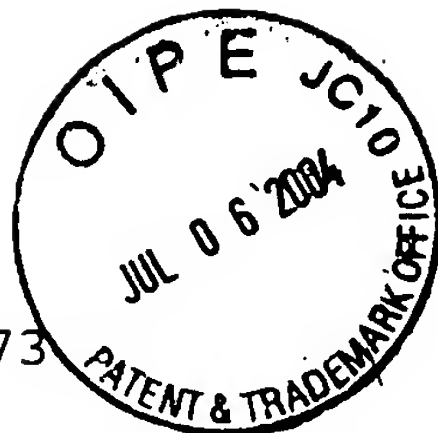


U.S.S.N. 10/087,673



1765  
Qsw

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Weng Chang

Group Art Unit: 1765

Serial No.: 10/087,673

Examiner: Binh X Tran

Filed: 03/02/2002

In Response to Office Action  
Dated: 04/01/2004

For: METHOD OF IMPROVING AN ETCHING PROFILE IN DUAL DAMASCENE  
ETCHING

Attorney Docket No.: 67,200-691

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Va 22313-1450.

Date:

July 1/04

  
Kathy Dixon

RESPONSE TO OFFICE ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 04/01/2004

please consider the following remarks.